



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Landon B. Vines

Atty. Docket: US018074

Filed: May 31, 2001

Title: A CMP POLISHER SUBSTRATE REMOVAL CONTROL MECHANISM AND METHOD

Commissioner for Patents, Washington, D.C. 20231

APPOINTMENT OF ASSOCIATES

Sir:

The undersigned Attorney of Record hereby revokes all prior appointments (if any) of Associate Attorney(s) or Agent(s) in the above-captioned case and appoints:

GWENAELLE LE PENNEC
JEROEN HEUVELMAN
KEVIN FORTIN
CHRIS HORGAN
PETER ZAWILSKI
MICHAEL SCHMITT

Limited Recognition under 37 CFR 10.9(b);
Limited Recognition under 37 CFR 10.9(b);
Registration No. 35,140;
Registration No. 40,394;
Registration No. 43,305; and
Registration No. 36,921

c/o PHILIPS ELECTRONICS NORTH AMERICA CORPORATION, Corporate Intellectual Property, 580 White Plains Road, Tarrytown, New York 10591, his Associate Attorneys/Agents with all the usual powers to prosecute the above-identified application and any division or continuation thereof, to make alterations and amendments therein, and to transact all business in the Patent and Trademark Office connected therewith.

ALL CORRESPONDENCE CONCERNING THIS APPLICATION AND THE LETTERS PATENT WHEN GRANTED SHOULD BE ADDRESSED TO THE UNDERSIGNED ATTORNEY OF RECORD.

Respectfully,

By

Edward Blocker, Reg. 30,245
Attorney of Record

Dated at Sunnyvale, California

On 9/25/02

RECEIVED
OCT 1 - 2002
TECHNOLOGY CENTER R3700